

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date July 20, 2005

In re the Application of

Kazuo ICHIKAWA et al.

Application No.: 09/670,877

Filed: September 27, 2000

For: CVD SUBSTRATE AND CLEANING METHOD

Group Art Unit: 1763

Examiner: R. ZERVIGON

Docket No.: 107469

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired June 21, 2005, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 168892 in the amount of \$120 in payment for:

  X   Extension fee for response within first month pursuant to §1.136(a) (\$120.00)  
       Extension fee for response within second month pursuant to §1.136(a) (\$450.00)  
       Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

Yong S. Choi  
Registration No. 43,324

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JAO:YSC/mdw

OLIFF & BERRIDGE, PLC  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE  
AUTHORIZATION  
Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461